

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Brask

Examiner: Kathleen Duda

Application No.: 10/658,225

Art Unit: 1756

Filed: September 8, 2003

For: METHODS AND COMPOSITIONS
FOR SELECTIVELY ETCHING METAL
FILMS AND STRUCTURES

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**RESPONSE TO FINAL OFFICE ACTION UNDER 37 C.F.R §1.116
EXPEDITED PROCEDURE**

Dear Examiner:

This is in response to the Final Office Action mailed June 25, 2007. Applicants respectfully request the Examiner to enter this Amendment and consider the following remarks. Filed concurrently herewith are two Terminal Disclaimers to Obviate the Double Patenting Rejections Over Prior Patents (US 6,974,764 and US 7,129,182).

Amendments to the Specification begin on page 2.

Amendments to the Claims begin on page 3.

Remarks begin on page 7.

Filed via EFS Web: August 27, 2007